

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q92709

Masahiko ISHIDA , et al.

Application No.: 10/564,750

Group Art Unit: 1792

Confirmation No.: 1790

Examiner: Felisa Carla HITESHEW

Filed: January 17, 2006

For: METHOD FOR FIXING METAL PARTICLES AND METHOD FOR  
MANUFACTURING SUBSTRATE CONTAINING METAL PARTICLES, METHOD  
FOR MANUFACTURING SUBSTRATE CONTAINING CARBON NANOTUBE, AND  
METHOD FOR MANUFACTURING SUBSTRATE CONTAINING  
SEMICONDUCTOR-CRYSTALLINE ROD, EMPLOYING

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated September 24, 2008, please amend the above-identified application as follows on the accompanying pages. The Amendment is being filed along with a Petition for Extension of Time for one month, thereby extending the date of response from December 24, 2008 to January 24, 2009. Therefore, the response is timely filed.

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